

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of:	<b>Yoshihide SENZAKI</b>	Confirmation No.:	<b>2634</b>
Serial No.	<b>10/521,636</b>	Art Unit:	<b>2813</b>
Filed:	<b>January 19, 2006</b>	Examiner:	<b>Nguyen, Tuan H.</b>
For:	<b>In-Situ Formation of Metal Insulator Metal Capacitors</b>	Attorney Docket No:	<b>067538-5167-US (previously A-71644/MSS (463035-877))</b>

**TRANSMITTAL OF POWER OF ATTORNEY BY ASSIGNEE  
REVOKING PREVIOUS POWERS OF RECORD**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant's attorney encloses herewith a Revocation and Power of Attorney by Assignee with Statement Under 37 CFR 3.73(b) for the above identified application.

Please change the attorney docket number to 067538-5167-US. Future correspondence should be forwarded to customer no. **24341**.

The Commissioner is authorized to charge any fees associated with this communication to Morgan, Lewis & Bockius LLP deposit account no. 50-0310 (order no. 067538-5167-US).

Date: December 21, 2007

Respectfully submitted,



Maria S. Swiatek

37,244

(Reg. No.)

**Customer No. 24341**

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